



11/14/02  
#12/JDS

EV077334478

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. ....  
Filing Date ..... 09/885,393  
Inventor ..... June 19, 2001  
Assignee ..... Richard Holscher et al.  
Group Art Unit ..... Micron Technology, Inc.  
Examiner ..... 1756  
Attorney's Docket No. .... K. Duda  
Title: Semiconductor Processing Methods ..... MI22-1694

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, the Examiner's attention is directed to the reference listed on the attached Form PTO-1449 and a copy of which is attached. No admission is made regarding whether the submitted reference is prior art.

Citation of this patent is respectfully requested.

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TC 1700

Respectfully submitted,

Dated: 11-7-02

Attorney: 

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